



**ELECTRONIC COPY**

LG770660425  
Report verification at igi.org



February 2, 2026  
IGI Report Number **LG770660425**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **11.27 X 7.78 X 5.25 MM**  
**GRADING RESULTS**  
Carat Weight **4.02 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**LABORATORY GROWN DIAMOND REPORT**

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Measurements **11.27 X 7.78 X 5.25 MM**

**GRADING RESULTS**

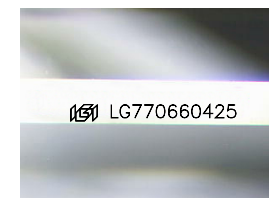
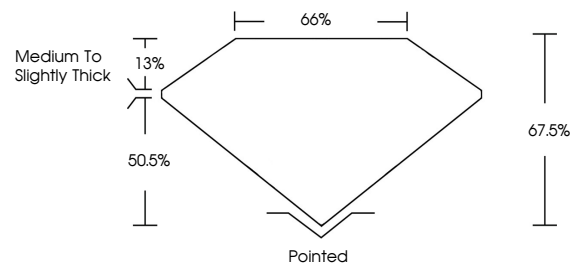
Carat Weight **4.02 CARATS**  
Color Grade **E**  
Clarity Grade **VS 1**

**ADDITIONAL GRADING INFORMATION**

Polish **EXCELLENT**  
Symmetry **EXCELLENT**  
Fluorescence **NONE**  
Inscription(s) **IGI LG770660425**

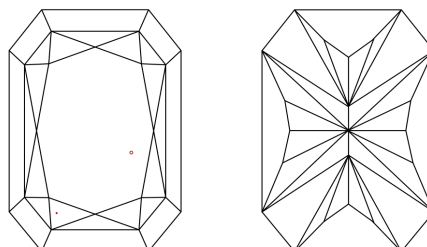
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



Sample Image Used

**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

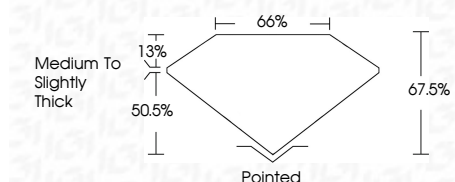
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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CUT CORNERED RECT. MODIFIED BRILLIANT  
11.27 X 7.78 X 5.25 MM  
4.02 CARATS  
E  
VS 1  
67.5%  
50.5%  
Medium to Slightly Thick  
Pointed  
EXCELLENT  
EXCELLENT  
NONE  
IGI LG770660425

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Type IIa